Form 1449 (Modified)

Atty Docket No. Application No.:

NOVLP033X1/NVLS000498X1

Applicant:

Statement By Applicant

Lee et al.

Filing Date

Group

August 26, 2003

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date
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Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Transl	ation
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No

Other Documents

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Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	Cl	Levy et al., "Deposition of Tungsten Nitride", Novellus Systems, Inc., filed
a		December 16, 2005, Application No. 11/305,368, pages 1-39.
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Examiner		Chury a Date Considered 7/11/06
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Form 1449 (Modified)

Atty Docket No. NOVLP033X1/NVLS- Application No.: 10/649,351

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Information Disclosure Statement By Applicant

Applicant: Lee et al. Filing Date

Group

(Use Several Sheets if Necessary)

August 26, 2003

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Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Trans	lation
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No

Other Documents

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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.